

Docket No.: GR 97 P 2659 P



GPLB 7568nsd
#6 9-14-00
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By: h p. ~

Date: 9/8/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Vincenzo Scotto Di Carlo et al.
Application No. : 09/538,792
Filed : March 30, 2000
Title : Method for Giving Notification of a Message to a Subscriber
Art Unit : 2748

TECH CENTER 2700

SEP 14 2000

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INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

German Published, Non-Prosecuted Patent Application DE 43 32 057 A1 (Werner), dated March 30, 1995, integrated micro mechanical sensor configuration and method for its production;

German Published, Non-Prosecuted Patent Application DE 44 14 968 A1 (Zettler), dated November 2, 1995; micro system with integrated circuit and micro mechanical component and production process;

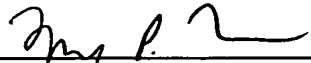
Euisik Yoon et al.: "An integrated Mass Flow Sensor with On-Chip CMOS Interface Circuitry", IEEE Transactions on Electron devices, Vol. 39, No. 6, June 1992, pp. 1376-1385;

S. Middelhoek et al.: "Silicone sensors", Meas. Sci. Technol. 6 (1995), pp. 641-1658.

If no translation of pertinent portions of any foreign language patents or publications mentioned above is included with the aforementioned copies of those applications, patents and or publications, it is because no existing translation is readily available to the applicant.

Respectfully submitted,

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For Applicants

Date: 9/8/00

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